

Form PTO-1749

**INFORMATION DISCLOSURE CITATION
IN THIS APPLICATION**

(Use several sheets if necessary)

 ATTY. DOCKET NO.
2360-0342P

 APPLICATION NO.
09/886,385

 APPLICANT
Heinz WEBER et al.

 FILING DATE
June 22, 2001

 GROUP
2828
U.S. PATENT DOCUMENTS

| EXAMINER INITIAL | DOCUMENT NUMBER | Kind | DATE | NAME | CLASS | SUB CLASS | FILING DATE IF APPROPRIATE |
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FOREIGN PATENT DOCUMENTS

| Office | DOCUMENT NUMBER | Kind | DATE | COUNTRY | CLASS | SUB CLASS | TRANSLATION | |
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OTHER DOCUMENTS

(Include Name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.

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| la | T. Y. Cherezova et al., "ACTIVE CORRECTORS AS THE ALTERNATIVE TO GRADED PHASE MIRRORS - CO ₂ AND YAG LASER BEAM FORMATION," Institute of Laser Information Technologies, Russia, July 12-16, 1999, pages 187-192 |
| la | Alexis KUDRYASHOV et al., "BIMORPH MIRRORS FOR CORRECTION AND FORMATION OF LASER BEAMS," Adaptive Optics for Industry and Medicine Group, Institute on Laser and Information Technologies, Russia, July 12-16, 1999, pages 193-199 |
| la | C. STEWEN et al., "Yb:YAG thin disk laser with 1 kW output power," Trends in Optics and Photonics, TOPS Vol. 34, February 13-16, 2000, pages 35-41 |
| | |

EXAMINER

Heinz Weber

DATE CONSIDERED

4/4/04

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